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APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.
10/590,046	06/15/2007	Taku Hirayama	SHIGA7.055APC 5635	
	7590 07/20/201 RTENS OLSON & BE	EXAMINER		
2040 MAIN ST	REET	JOHNSON, CONNIE P		
FOURTEENTH FLOOR IRVINE, CA 92614		ART UNIT	PAPER NUMBER	
			1795	
		NOTIFICATION DATE	DELIVERY MODE	
			07/20/2010	ELECTRONIC

Please find below and/or attached an Office communication concerning this application or proceeding.

The time period for reply, if any, is set in the attached communication.

Notice of the Office communication was sent electronically on above-indicated "Notification Date" to the following e-mail address(es):

jcartee@kmob.com efiling@kmob.com eOAPilot@kmob.com

		Application No.	Applicant(s)			
Office Action Summary		10/590,046	HIRAYAMA ET AL.			
Office Action Sum	iiai y	Examiner	Art Unit			
		CONNIE P. JOHNSON	1795			
The MAILING DATE of this Period for Reply	communication app	ears on the cover sheet with the c	orrespondence address			
after SIX (6) MONTHS from the mailing date - If NO period for reply is specified above, the - Failure to reply within the set or extended pe	M THE MAILING DA ne provisions of 37 CFR 1.13 of this communication. maximum statutory period v riod for reply will, by statute, ree months after the mailing		N. nely filed the mailing date of this communication. D (35 U.S.C. § 133).			
Status						
1)⊠ Responsive to communicat	ion(s) filed on <u>17 Ju</u>	<u>ıne 2010</u> .				
2a) ☐ This action is FINAL .	This action is FINAL . 2b)⊠ This action is non-final.					
3)☐ Since this application is in €	☐ Since this application is in condition for allowance except for formal matters, prosecution as to the merits is					
closed in accordance with t	he practice under <i>E</i>	x parte Quayle, 1935 C.D. 11, 45	i3 O.G. 213.			
Disposition of Claims						
4)⊠ Claim(s) <u>1-20</u> is/are pendir 4a) Of the above claim(s) _ 5)□ Claim(s) is/are allow 6)⊠ Claim(s) <u>1-20</u> is/are rejecte 7)□ Claim(s) is/are object 8)□ Claim(s) are subject	is/are withdraved. d. cted to.	vn from consideration.				
Application Papers						
	is/are: a) ☐ according any objection to the objection is a constant.	epted or b) objected to by the Eddrawing(s) be held in abeyance. See ion is required if the drawing(s) is obj	e 37 CFR 1.85(a). lected to. See 37 CFR 1.121(d).			
Priority under 35 U.S.C. § 119						
2. Certified copies of th3. Copies of the certifie application from the	one of: e priority document: e priority document: d copies of the prior International Bureau	priority under 35 U.S.C. § 119(a) is have been received. In Application of the certified copies not received the certified copies not received.	on No ed in this National Stage			
Attachment(s) 1) Notice of References Cited (PTO-892)		4)	(PTO-413)			
 2) Notice of References Cited (P10-892) 3) Notice of Draftsperson's Patent Drawing 3) Information Disclosure Statement(s) (P' Paper No(s)/Mail Date 4/9/10 and 5/12/ 	ΓO/SB/08)	4)	nte			

DETAILED ACTION

Response to Amendment

- 1. The remarks and amendment filed 6/17/2010 are entered and fully considered.
- 2. Claims 1-20 are presented.

Double Patenting

3. The nonstatutory double patenting rejection is based on a judicially created doctrine grounded in public policy (a policy reflected in the statute) so as to prevent the unjustified or improper timewise extension of the "right to exclude" granted by a patent and to prevent possible harassment by multiple assignees. A nonstatutory obviousness-type double patenting rejection is appropriate where the conflicting claims are not identical, but at least one examined application claim is not patentably distinct from the reference claim(s) because the examined application claim is either anticipated by, or would have been obvious over, the reference claim(s). See, e.g., *In re Berg*, 140 F.3d 1428, 46 USPQ2d 1226 (Fed. Cir. 1998); *In re Goodman*, 11 F.3d 1046, 29 USPQ2d 2010 (Fed. Cir. 1993); *In re Longi*, 759 F.2d 887, 225 USPQ 645 (Fed. Cir. 1985); *In re Van Ornum*, 686 F.2d 937, 214 USPQ 761 (CCPA 1982); *In re Vogel*, 422 F.2d 438, 164 USPQ 619 (CCPA 1970); and *In re Thorington*, 418 F.2d 528, 163 USPQ 644 (CCPA 1969).

A timely filed terminal disclaimer in compliance with 37 CFR 1.321(c) or 1.321(d) may be used to overcome an actual or provisional rejection based on a nonstatutory double patenting ground provided the conflicting application or patent either is shown to be commonly owned with this application, or claims an invention made as a result of activities undertaken within the scope of a joint research agreement.

Effective January 1, 1994, a registered attorney or agent of record may sign a terminal disclaimer. A terminal disclaimer signed by the assignee must fully comply with 37 CFR 3.73(b).

4. Claims 1-5, 8-13 and 16-20 are provisionally rejected on the ground of nonstatutory obviousness-type double patenting as being unpatentable over claims 1, 6 and 9 of copending Application No. 11/574,805. Although the conflicting claims are not identical, they are not patentably distinct from each other because the copending application discloses a resist composition comprising a base material with acid-dissociable, dissolution-inhibiting groups, an acid generator and a nitrogen-containing compound.

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This is a <u>provisional</u> obviousness-type double patenting rejection because the conflicting claims have not in fact been patented.

5. Claims 1-5, 8-13 and 16-20 are provisionally rejected on the ground of nonstatutory obviousness-type double patenting as being unpatentable over claims 1 and 2 of copending Application No. 11/813,511. Although the conflicting claims are not identical, they are not patentably distinct from each other because the copending application discloses a resist composition comprising a polyhydric phenol compound with acid-dissociable, dissolution-inhibiting groups with a molecular weight of 300 to 2500, an acid generator and a nitrogen-containing compound. Although not exemplified in the claims, it would have been obvious to one of ordinary skill in the art that the polyhydric phenol compound is present in the amount as claimed based the components in table 1, page 13.

This is a <u>provisional</u> obviousness-type double patenting rejection because the conflicting claims have not in fact been patented.

6. Claims 1-5, 8-13 and 16-20 are provisionally rejected on the ground of nonstatutory obviousness-type double patenting as being unpatentable over claims 1-6 of copending Application No. 11/914,451. Although the conflicting claims are not identical, they are not patentably distinct from each other because the copending application discloses a resist composition comprising a polyhydric phenol compound with acid-dissociable, dissolution-inhibiting groups with a molecular weight of 300 to 2500, an acid generator and a nitrogen-containing compound. Although not exemplified in the claims, it would have been obvious to one of ordinary skill in the art that the

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polyhydric phenol compound is present in the amount as claimed based the components

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in table 4, page 20.

This is a provisional obviousness-type double patenting rejection because the conflicting

claims have not in fact been patented.

Claims 1-5, 8-13 and 16-20 are provisionally rejected on the ground of 7.

nonstatutory obviousness-type double patenting as being unpatentable over claims 1-7

of copending Application No. 11/994,602. Although the conflicting claims are not

identical, they are not patentably distinct from each other because the copending

application discloses a resist composition comprising a base material with acid-

dissociable, dissolution-inhibiting groups with a molecular weight of 300 to 2500, an

acid generator and a nitrogen-containing compound. Although not exemplified in the

claims, it would have been obvious to one of ordinary skill in the art that the polyhydric

phenol compound is present in an amount as claimed based on the components in table

3 (page 19).

This is a provisional obviousness-type double patenting rejection because the conflicting

claims have not in fact been patented.

Claim Rejections - 35 USC § 102

8. The following is a quotation of the appropriate paragraphs of 35 U.S.C. 102 that

form the basis for the rejections under this section made in this Office action:

A person shall be entitled to a patent unless -

(a) the invention was known or used by others in this country, or patented or described in a printed

publication in this or a foreign country, before the invention thereof by the applicant for a patent.

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9. Claims 1-20 are rejected under 35 U.S.C. 102(a) as being anticipated by Hirayama et al., IEEE Xplore, (October 22, 2004).

Hirayama teaches a positive resist composition comprising a polyphenol that is representative of the structure in present claim 2, formula (I), wherein p=1 (page 11, Figure 1, structure 3M6C-MBSA and 25X-MBSA). The 3M6C-MBSA and 25X-MBSA have a phenolic hydroxyl group R=ethoxyethyl in a protection ratio of 19.9-30mol% (claim 17) (table 1). Therefore, 3M6C-MBSA and 25X-MBSA would have two-OH groups protected with ethoxyethyl groups and one-unprotected hydroxyphenol wherein R=hydrogen, based on the ratio of protection groups. So, the amount of protected groups would be greater than 80% by weight and less than 20% by weight of unprotected groups. The polyphenols have a molecular weight of 981.4 and 708.9, respectively. Therefore the compounds have an inherent molecular dispersity of no more than 1.5. The low molecular weight polyphenol is present in the resist composition in an amount of 100% by weight (claim 1). There are no other acid-dissociable group containing compounds in the resist composition. The recitation, "an ability to form an amorphous film using a spin coating method" is intended use and does not add positive recitation to the claim. Applicant is reminded of MPEP 2106. The resist composition also comprises triphenylsulfonium perfluoro-1-butanesulfonate as a photoacid generator and tri-octylamine as the nitrogen-containing compound (Table 1). The resist pattern is formed by applying the resist to a silicon wafer, prebaking (PAB), exposing, post exposure baking (PEB) and developing to form a pattern (see explanation in figure

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2). Hirayama also teaches developing the positive resist with 0.26N tetramethylammonium hydroxide (page 10, paragraph 2).

Response to Arguments

10. Applicant's arguments filed 6/17/2010 have been fully considered but they are not persuasive. However, upon further consideration, a new ground(s) of rejection is made herein.

11. Applicant argues that since the Obviousness Double Patenting rejection is the only remaining rejection, that the rejection should be withdrawn.

However, since no terminal disclaimer has been filed, the Obviousness type Double Patenting rejections are maintained.

Conclusion

Any inquiry concerning this communication or earlier communications from the examiner should be directed to CONNIE P. JOHNSON whose telephone number is (571)272-7758. The examiner can normally be reached on 7:30am-4:00pm Monday thru Friday.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Cynthia Kelly can be reached on 571-272-1526. The fax phone number for the organization where this application or proceeding is assigned is 571-273-8300.

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Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free). If you would like assistance from a USPTO Customer Service Representative or access to the automated information system, call 800-786-9199 (IN USA OR CANADA) or 571-272-1000.

Connie P. Johnson Examiner Art Unit 1795 Page 7

/Cynthia H Kelly/ Supervisory Patent Examiner, Art Unit 1795